APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention

METHOD FOR PATTERNING A SEMICONDUCTOR REGION

Application Type: regular, utility

Attorney Docket Number: FIS920040061US1

Correspondence address:

Customer Number: 32074

Inventors Information:

Inventor 1:

Applicant Authority Type: Inventor

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Inventor 2:

Applicant Authority Type: Inventor

Citizenship: IN

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Address-1 of Mailing Address:	2 Noel Court
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State of Mailing Address:	NY
Postal Code of Mailing Address:	10509
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Applicant Authority Type:	Inventor
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Assigned 1	
Assignee 1:	International Pusiness Machines Corporation
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